

Video Measuring System



VMZ-K Series

Confocal Model



NEXIV VMZ-K Series

3D FOV Measurements Generated with Confocal Images

A ground-breaking multifunctional video measuring system developed on the strength of Nikon's leading optomechatronics technology.

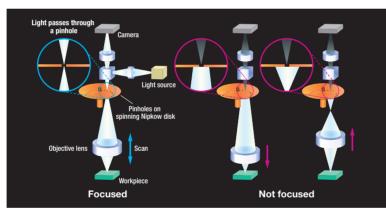
- Combines confocal optics and brightfield optics, for fast and accurate evaluation of fine threedimensional geometries

- Allows both 2D and height measurements in the same field of view

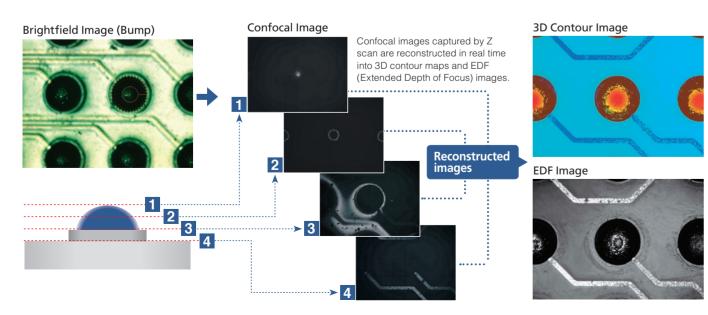
This series can be optimally used for inspecting precise 3D-shaped samples, including micro bumps, circuit patterns, and bonding wires, as well as samples with countless points, such as probe cards. The VMZ-K series can also measure both the shallow recesses and gentle ledges on PCBs.

Principle of Confocal Optics

Light passing through a pinhole on a spinning Nipkow disk is reflected by the workpiece at the focal point, back through the pinhole. This light is detected as a very narrow DOF confocal image by the camera. If there is no workpiece at the focal point, the light does not reflect back through the pinhole. By moving the focal plane in the vertical direction, the Confocal NEXIV VMZ-K series samples multiple confocal images and combines them to compose a confocal image with height information, provided by Nikon's unique interpolation technology.



Nikon-Original Low Flare Confocal Optics



The VMZ-K series enables microscopic height measurements using various objective lenses, with two models to choose from, each featuring different stage strokes.

VMZ-K3040 Type-S/Type-H

Main Features

General model for a wide range of needs

Main Applications

- Microscopic bumps in advanced IC packages
- Probe cards
- Precision optical components
- Microscopic laser marks on semiconductor wafers
- MEMS
- Wire bonding

VMZ-K6555 Type-S/Type-H

Main Features

Handles printed circuit board sizes with its 650 x 550 mm stroke

Main Applications

- PCB with precise circuit patterns
- Probe cards
- LCD-related components

Objectives

Nikon offers five different objective types, enabling users to choose the optimal magnification model for the application.

			Type-S	Туре-Н				
Magnification		1.5×	З×	7.5×	15×	30×		
Working Distance		35 mm *1	24 mm	5 mm	20 mm	5 mm		
Field of View	Confocal	8 × 6 mm	4 × 3 mm	1.6 × 1.2 mm	0.8 × 0.6 mm	0.4 × 0.3 mm		
	Brightfield	8 × 6 to 0.53 × 0.4 mm	4 × 3 to 0.27 × 0.2 mm	1.6 × 1.2 to 0.11 × 0.08 mm	1.26 × 0.95 to 0.1 × 0.074 mm	0.63 × 0.47 to 0.05 × 0.04 mm		

*1: Ring illumination only has a traveling distance of 24 mm.

W (mm)× L (mm)	8 6	4 3	2.0 1.5	1.6 1.2	1.26 0.95	1.00 0.75	0.8 0.6	0.63 0.47	0.53 0.40	0.4 0.3	0.27 0.20	0.20 0.15	0.11 0.08	0.100 0.074	0.05 0.04	Working distance
1.5 ×	-															24 mm
3 ×		•														24 mm
7.5 ×				•												5 mm
15 ×					-		- 9									20 mm
30 ×								•		- 0						5 mm
	L (mm) 1.5 × 3 × 7.5 × 15 ×	L (mm) 6 1.5 × ● 3 × 7.5 × 15 ×	L (mm) 6 3 1.5 × • • • • • • • • • • • • • • • • • •	L (mm) 6 3 1.5 1.5 × • • • 3 × • • • 7.5 × - - 15 × - -	L (mm) 6 3 1.5 1.2 1.5 × • • • • 3 × • • • • 7.5 × • • • 15 × • • •	L (mm) 6 3 1.5 1.2 0.95 1.5 × • • • • • 3 × • • • • 7.5 × • • • • 15 × • • • •	L (mm) 6 3 1.5 1.2 0.95 0.75 1.5 x 9 9 9 9 9 3 x 9 9 9 9 7.5 x 9 9 9 9 15 x 9 9 15 x 9 9 15 x 9 9 15 x	L (mm) 6 3 1.5 1.2 0.95 0.75 0.6 1.5 × • • • • • • • • • • • • • • • • • •	L (mm) 6 3 1.5 1.2 0.95 0.75 0.6 0.47 1.5 x • • • • • • • 3 x • • • • • • • 7.5 x • • • • • • 15 x • • • • •	L (mm) 6 3 1.5 1.2 0.95 0.75 0.6 0.47 0.40 1.5 × • • • • • • • • • 3 × • • • • • • • • • 7.5 × • • • • • • • • 15 × • • • • • • • •	L (mm) 6 3 1.5 1.2 0.95 0.75 0.6 0.47 0.40 0.3 1.5 x •	L (mm) 6 3 1.5 1.2 0.95 0.75 0.6 0.47 0.40 0.3 0.20 1.5 × •	L (mm) 6 3 1.5 1.2 0.95 0.75 0.6 0.47 0.40 0.3 0.20 0.15 1.5 x •	L (mm) 6 3 1.5 1.2 0.95 0.75 0.6 0.47 0.40 0.3 0.20 0.15 0.08 1.5 x • </td <td>L (mm) 6 3 1.5 1.2 0.95 0.75 0.6 0.47 0.40 0.3 0.20 0.15 0.08 0.074 1.5 x • <td< td=""><td>L (mm) 6 3 1.5 1.2 0.95 0.75 0.6 0.47 0.40 0.3 0.20 0.15 0.08 0.074 0.04 1.5 x •</td></td<></td>	L (mm) 6 3 1.5 1.2 0.95 0.75 0.6 0.47 0.40 0.3 0.20 0.15 0.08 0.074 1.5 x • <td< td=""><td>L (mm) 6 3 1.5 1.2 0.95 0.75 0.6 0.47 0.40 0.3 0.20 0.15 0.08 0.074 0.04 1.5 x •</td></td<>	L (mm) 6 3 1.5 1.2 0.95 0.75 0.6 0.47 0.40 0.3 0.20 0.15 0.08 0.074 0.04 1.5 x •

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Applications

High performing GUI and sophisticated software functionality provides the easiest and guickest 3D metrology

Teaching Generation/Replay



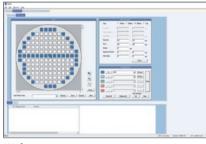
 Both 2D measurement of brightfield images and height measurement of 3D images are possible in the same field of view, at high speeds and with high accuracy.

• In addition to the measurement tools employed by the NEXIV series, 3D feature measurement tools are available for diverse workpiece shapes, such as ball/flat bumps, bonding wires, and probe card pins. The optimized algorithms for measurement sequence enable simultaneous measurement of multiple points in the field of view.

 Measurement results are stored as CSV format ASCII data for Data Reporting/SPC Analysis.

User-friendly operations enhance efficiency of semiconductor wafer and PCB chip measurements.

Map Recipe Generation





• Any chip on the generated map can simply be measured by inputting chip size and pitch.

• Map generation can also be done on PCBs, composed of groups of chips.

• A specified die can be easily measured

• The workpiece being measured can be

viewed by changing to the image tab.

by inputting map recipe file, ID, and lot

number.

10100

Wafer

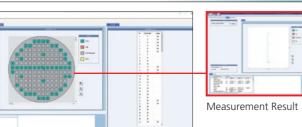
Map Measurement Execution

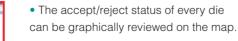




Image Tab

Measurement Result Review

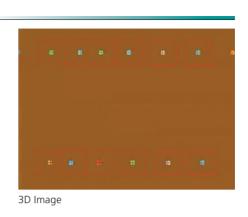




• A result screen is shown when a die is selected, king it easy to verify each die's measurement results.

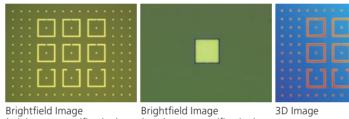
Probe Cards

Programming can be made from location data in one click, XYZ coordinates and coplanarity contact probe pins on probe cards be automatically measured with unique image processing tools.



Fine Bump and Substrate Pattern

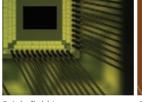
A combination of 2D measurement with 15x zoom brightfield image and 3D height measurement in the same field of view enables diverse measurements.



(minimum magnification)

(maximum magnification)

Bonding Wire Loop Height



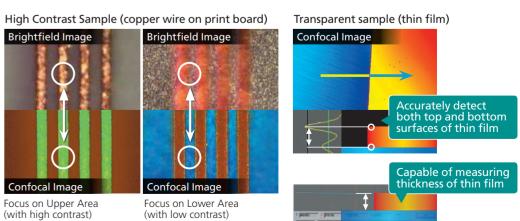
Brightfield Image

3D Image: simultaneous detection of the highest point of all wires

3D Image: display of wire height profile

Precise PCB Pattern

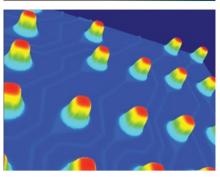
Accurate measurement of high contrast samples tends to be difficult with brightfield illumination because their edges appear unclear. Confocal optics enables a clear display, and facilitates accurate detection of sample edges.



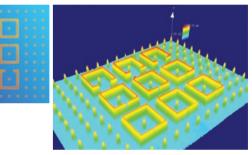
(with high contrast)



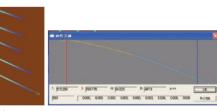




Bird's-eye View Image with 3D Viewer Software (option)



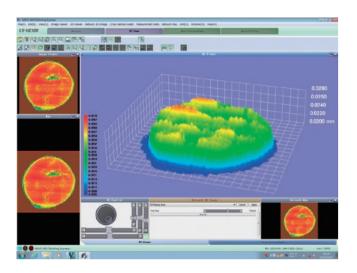
Bird's-eye View Image by 3D Viewer Software option)

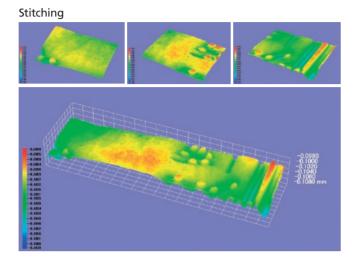


Optional Hardware

Image Archiving and Processing Software - EDF/Stitching Express

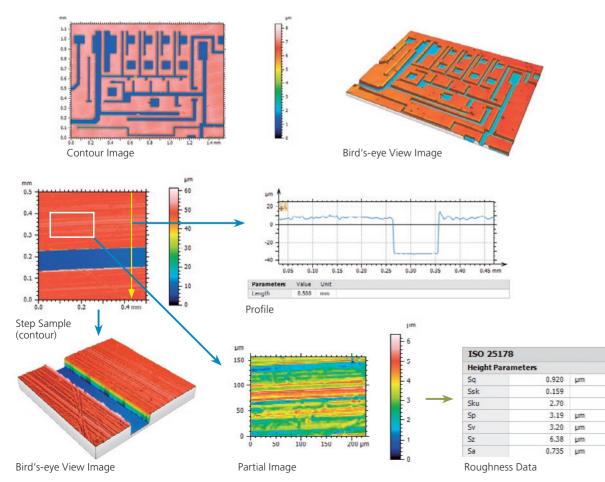
The EDF/Stitching Express software creates an image archiving library for confocal and brightfield images, and provides post-image processing functionalities, such as EDF and large-area image stitching.





3D Surface Metrology Analysis Software - MountainsMap X

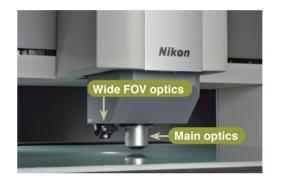
The MountainsMap X is a powerful software for surface metrology analysis. It provides the rich functionality of 3D visualization, crosssectional view, 2D and 3D roughness, and other parameters based on the latest ISO standards.



Wide FOV Optics (for high-magnification optical heads)

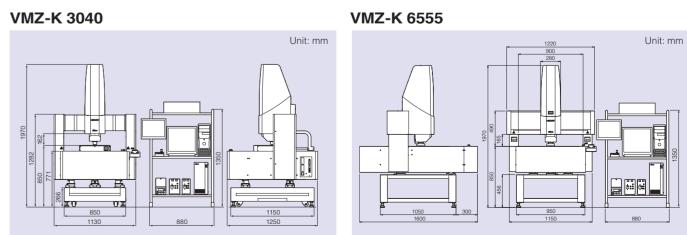
Wide field of view optics aids in the selection of the area to be measured and the creation of programs with high-magnification optical heads.

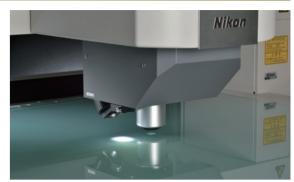
Compatible optical head	15×, 30×				
Field of view	4.8 mm × 3.6 mm				
Working distance	40.6 mm				
Main optical head offset	64 mm				
Illumination	Episcopic illumination only				
Wide FOV optics effective ranges (mm)	VMZ-K3040: 236(X) × 400(Y) VMZ-K6555: 586(X) × 550(Y)				





Dimensional Diagram







30× Objective 1× (0.4 mm × 0.3 mm)

Specifications

Model	VM	Z-K3040 Typ	e-S	VMZ-K304	10 Type-H	VM	Z-K6555 Typ	VMZ-K6555 Type-H High-magnification head					
		Standard he	ad	High-magnit	fication head	5	Standard hea						
Objectives													
Magnification	ation 1.5× 3× 7.5× 15× 30:		30×	1.5×	1.5× 3× 7.5× 15			30×					
Working distance (*with ring illumination)	24 mm*	24 mm	5 mm	20 mm	5 mm	24 mm*	24 mm 5 mm		20 mm	5 mm			
Confocal Optics (Area	a height mea	surement)											
Maximum scan height	1 mm												
Field of view	8×6 mm	4×3 mm	1.6×1.2 mm	0.8 ×0.6 mm	0.4×0.3 mm	8×6 mm	4×3 mm	1.6×1.2 mm	0.8×0.6 mm	0.4×0.3 mm			
Height measurement repeatability (2σ)	0.6 µm	0.35 µm	0.25 µm	μm 0.25 μm 0.2 μ		0.6 µm	0.35 µm	0.25 µm	0.25 µm	0.2 µm			
Height resolution					0.01	μm							
Field of view	8×6 to 0.53×0.4 mm	4×3 to 0.27×0.2 mm	1.6×1.2 to 0.11×0.08 mm	1.26×0.95 to 0.1×0.074 mm	0.63×0.47 to 0.05×0.04 mm	8×6 to 0.53×0.4 mm	4×3 to 0.27×0.2 mm	1.6×1.2 to 0.11×0.08 mm	1.26×0.95 to 0.1×0.074 mm	0.63×0.47 to 0.05×0.04 mm			
Illumination	Diascopic,	scopic, coaxial episcopic and ring Diascopic and coaxial episcopic Diascopic, coaxial episcopic and ring Diascopic and coaxia											
Light source	White LED												
Autofocus	Vision AF, Laser AF												
Main Body													
XYZ strokes		300 mm × 400 mm × 150 mm					650 mm × 550 mm × 150 mm						
Accuracy guaranteed loading capacity			20kg			30kg							
Maximum permissible error (L: Length in mm)		EUX, MPE EU EUXY, MPE: 2.3 EUZ, MPE: 1 +	5 + 4 <i>L</i> /1000			Eux, мре Euy, мре: 1.5 + 2.5 <i>L</i> /1000 μm Euxy, мре: 2.5 + 2.5 <i>L</i> /1000 μm Euz, мре: 1 + <i>L</i> /1000 μm							
Power source	AC 100 – 240 V ± 10% 50/60 Hz												
Power consumption	10A – 5A												
Operating conditions	Temperature: 20°C ± 0.5 K, Humidity: 70 % or less												
Acquired standard	CE marking (low voltage/EMC/laser)												
Dimensions and weig	ht												
Main body and table			1250 × 1970 prox. 800 kg			1220 × 1600 × 1970 mm approx. 800 kg							
Controller				1	$90 \times 450 \times 4$	40 mm / 20 k	g						
Installation area (W×D)		25	00 × 1600 m	m			25	500 × 1900 n	าท				

*Please contact Nikon for permissible floor vibration specifications.

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WARNING TO ENSURE CORRECT USAGE, READ THE CORRESPONDING MANUALS CAREFULLY BEFORE USING THE EQUIPMENT.



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